

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Geun-Young YEOM et al.

Title: 3-GRID NEUTRAL BEAM SOURCE USED FOR ETCHING
SEMICONDUCTOR DEVICE

Appl. No.: Unassigned

Filing Date: April 1, 2004

Examiner: Unassigned

Art Unit: Unassigned

PRELIMINARY AMENDMENT

Mail Stop NON-FEE AMENDMENT
Commissioner for Patents
PO Box 1450
Alexandria, Virginia 22313-1450

Sir:

Prior to examination of the present Application, Applicant respectfully requests that the application be amended as follows:

Amendments to the Specification begin on page 2 of this document.

Remarks/Arguments begin on page 4 of this document.

Please amend the application as follows: